## TRANSMITTAL FORM

(to be used on all correspondence after initial ling)

DEC 1 8 2006

ATTORNEY DOCKET NO. 70020.0076USWO

U.S. APPLICATION SERIAL NO. 10/576,075

CONFIRMATION NO. 6664

FILING DATE

Unassigned

**April 14, 2006** EXAMINER

GROUP ART UNIT

Unassigned

INVENTOR(S)

Isao NISHIMURA et al.

TITLE OF APPLICATION

SILANE COMPOUND, POLYSILOXANE, AND RADIATION-SENSITIVE RESIN COMPOSITION

ADDRESS TO:	Mailstop Amendment Commissioner for Patents P.O. BOX 1450 ALEXANDRIA, VA 22313-1450	ENCLOSURES	
<del></del>		LITOLOGOTICO	
PTO For	ion Disclosure Statement m 1449 (1 Sheet) Cited Documents (10)		
this amount and the P	atent Office charges for filing the above-no	oted documents, including ocuments timely, please c	ired fees. In the event any variance exists between any fees required under 35 CFR 1.136 for any harge or credit the difference to Deposit Account No. made under 37 CFR 1.136 for the necessary
	CORRES	SPONDENCE ADDRE	SS
The address as	sociated with Customer Number: 2	3552 OR	the correspondence address below.
Name	and the second s		
Address			
City	State		Zip Code

NAME	Christopher W. Raimund		REGISTRATION NO.	47,258	
SIGNATURE	()	DATE	December 18, 2006	TELEPHONE	202 326-0300
NAME			REGISTRATION NO.		

DEC 1 8 7006 W

# INFORMATION DISCLOSURE STATEMENT

37 C.F.R. § 1.97(b)

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Mailstop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner.

This statement should be considered because it is submitted before the mailing date of a first Office Action on-the-merits. Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F.R. §1.98(a)(2), a copy of each document or other information listed on the enclosed Form 1449 is provided.

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested that the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

Please charge any additional fees or credit any overpayment to Deposit Account No. 13-2725.

December 18, 2006

Date

P.O. Box 2903 Minneapolis, Minnesota 55402-0903 Telephone No. (202) 326-0300 Facsimile No. (202) 326-0778

23552

Patent & Trademark Office

Respectfully submitted,

MERCHANT & GOULD, R.C.

Christopher W. Raimund Registration No. 47,258 DEC 1 8 2006

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

### INFORMATION DISCLOSURE STATEMENT (PTO 1449)

TOO20.0076USWO

U.S. APPLICATION SERIAL NO. CONFIRMATION NO

10/576,075

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			U.S.	PATENT DOCUMENTS			
EXAMINER INITIAL	,	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
:	Α						

		FOREI	GN PATENT DOCUMENT	S			
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANS	LATION NO
В	0 159 428 (Equivalent of JP6-12452)	04-13-1984	ЕР			X	
С	5-188598	07-30-1993	JP			х	
D	5-323611	12-07-1993	JР			х	
Е	6-12452	02-16-1994	JP			-	Х
F	8-160623	06-21-1996	JP			х	
G	11-60733	03-05-1999	JP			х	
Н	2002-220471	08-09-2002	JP			Х	
 1	2002-268225	09-18-2002	JP			х	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				
J	Kunz, R. R. et al., "Outlook for 157-nm Resist Design," Journal of Photopolymer Science and Technology, vol. 12(4), pp. 561-569, 1999.			
К	Kunz, R. R. et al., "Advances in Resist Technology and Processing XVI," Proceedings of SPIE, vol. 3678, pp. 13-23, 1999.			

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if the reference is considered, whether or not the citation is in conformance with MPEP 609. Draw a line through the citation if it is not in conformance and it is not considered. Include a copy of this form with the next communication to the Applicant.